



PTO/SB/30 (10-01)

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**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**Address to:
Commissioner for Patents
Box RCE
Washington, DC 20231

Application Number	09/254,939
Filing Date	March 17, 1999
First Named Inventor	H. Miura, et al
Art Unit	2814
Examiner Name	A. Mai
Attorney Docket Number	500.36904X00

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.
Request for Continued Examination (RCE) practice under 37 CFR 1.114 does not apply to any utility or plant application filed prior to June 8, 1995, or to any design application. See Instruction Sheet for RCEs (not to be submitted to the USPTO) on page 2.

1. **Submission** required under 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on **December 2, 2002**
(Any unentered amendment(s) referred to above will be entered).
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on
- iii. ☐ Other
- b. ☒ Enclosed
- i. ☒ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☐ Other

2. **Miscellaneous**

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of ____ months. (Period of suspension shall not exceed 3 months; Fee under 37 C.F.R. § 1.17(i) required)
- b. ☐ Other ____

3. **Fees** The RCE fee under 37 C.F.R. § 1.17 (e) is required by 37 C.F.R. § 1.114 when RCE is filed.

- a. ☒ The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No. **01-2135**
- i. ☐ RCE fee required under 37 C.F.R. § 1.17 (e)
- ii. ☐ Extension of time fee (37 C.F.R. §§ 1.136 and 1.17)
- iii. ☐ Other ____
- b. ☐ Check in the amount of \$ ____ enclosed
- c. ☒ Payment by credit card (Form PTO-2038 enclosed)

WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED

Name (Print/Type)	William I. Solomon	Registration No. (Attorney/Agent)	28,565
Signature	<i>William I. Solomon</i>	Date	January 30, 2003

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner For Patents, Box RCE, Washington, DC 20231, or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MIURA, et al.
Serial No.: 09/254,939
Filed: March 17, 1999
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE
HAVING TRENCH ELEMENT SEPARATION STRUCTURE
Group: 2814
Examiner: Anh D. Mai

**SUPPLEMENTING SUBMISSION
(AMENDMENT)**

Assistant Commissioner for Patents
Washington, D.C. 20231

January 30, 2003

Sir:

Supplementing the Amendment After Final Rejection filed December 2, 2002, which constitutes the necessary Submission in connection with the concurrently filed Request for Continued Examination (RCE) Transmittal, please further amend the above-identified application as follows:

IN THE CLAIMS

Please add the following new claims to the application:

--49. A method of fabricating a semiconductor device according to claim 1, wherein the oxidation prevention film is eliminated after said oxidizing only a portion of said semiconductor substrate.